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Examiner Signature		Date Considered	11/15/2005
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 18 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	Not yet assigned 10/813637
		Filing Date	March 3/31/2004
		First Named Inventor	JONES, Richard
		Group Art Unit	Not yet assigned 2883
		Examiner Name	Not yet assigned Derek Dupuis
Sheet 2 of 2	Attorney Docket Number	P-6478-US	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
DLD	4	Wiesmann, et al. "Large UV-Induced negative index changes in germanium-free nitrogen-doped planar SiO ₂ waveguides", Electronic Letters, Vol. 34, No. 4, Feb. 19, 1998, pages 364-366.	<input type="checkbox"/>
DLD	5	Wiesmann, et al. "Apodized Surface-Corrugated Gratings With Varying Duty Cycles", IEEE Photonics Technology Letters, Vol. 12, No. 6, June 2000, pages 639-641.	<input type="checkbox"/>
DLD	6	Maxwell, et al. "UV written 1-5µm reflection filters in single mode planar silica guides", Electronic Letters, Vol. 28, No. 22, Oct. 22, 1992, pages 2106-2107.	<input type="checkbox"/>
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